

GR/2812  
PATENTCase Docket No. ASMMC.036AUS  
Date: January 8, 2002

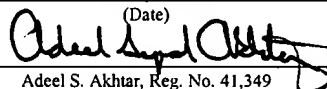
## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : SOPHIE et al.  
Appl. No. : 09/975,466  
Filed : October 9, 2001  
For : IN SITU REDUCTION OF  
COPPER OXIDE PRIOR TO  
SILICON CARBIDE  
DEPOSITION  
Examiner : Unknown  
Group Art Unit : 2812

I hereby certify that this correspondence and all  
marked attachments are being deposited with the  
United States Postal Service as first class mail in an  
envelope addressed to: Commissioner for Patents,  
Washington, D.C. 20231, on

January 8, 2002

(Date)

  
Adeel S. Akhtar, Reg. No. 41,349

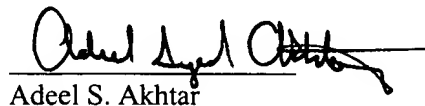
## TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A Form PTO-1449 with thirty-seven (37) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

  
Adeel S. Akhtar  
Registration No. 41,349  
Attorney of RecordRECEIVED  
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